



image AF/1765

PATENT

Atty. Dkt. No. AMAT/6060/CMP/ECP/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
Olgado, et al.

Serial No.: 10/043,561

Confirmation No.: 7947

Filed: January 8, 2002

For: System for Planarizing  
Metal Conductive Layers

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Group Art Unit: 1765

Examiner: Kin Chan Chen

MAIL STOP AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING	
37 CFR 1.8	
I hereby certify that this correspondence is being deposited on <u>12/19</u> , 2003 with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.	
<u>12/19/03</u> Date	<u>[Signature]</u> Signature

Dear Sir:

**RESPONSE TO FINAL OFFICE ACTION DATED OCTOBER 20, 2003**

In response to the Final Office Action dated October 20, 2003, having a shortened statutory period for response set to expire on January 20, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/6060/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

**The Pending Claims** are listed beginning on page 2 of this paper.  
**Remarks/Arguments** begin on page 10 of this paper.